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AMENDMENTS TO THE SPECIFICATION:

Please amend the specification, as follows:

Page 3, line 36, to page 4, line 7, please amend the paragraph, as follows:

In accordance with the [ninth] ninth feature of the invention, there is also provided a processing method of removing an oxide film from a surface of an object to be processed, the processing ~~apparatus~~ method comprising: allowing the oxide film formed on the surface of the object to react with active gas species under a condition of low temperature in a first processing chamber, thereby forming a product film; transporting the object having the product film formed thereon from the first processing chamber to a second processing chamber; and heating the product film formed on the surface of the object in the second processing chamber, to a predetermined temperature for vaporization, thereby removing the product film.

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